



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

December 16, 2025

IGI Report Number **LG758517432**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.12 - 8.15 X 4.94 MM**

#### GRADING RESULTS

Carat Weight **2.01 CARATS**

Color Grade **E**

Clarity Grade **VS 2**

Cut Grade **IDEAL**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

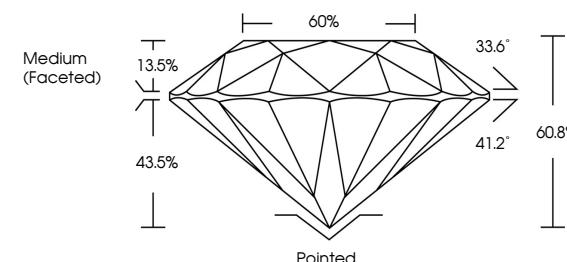
Inscription(s) **IGI LG758517432**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

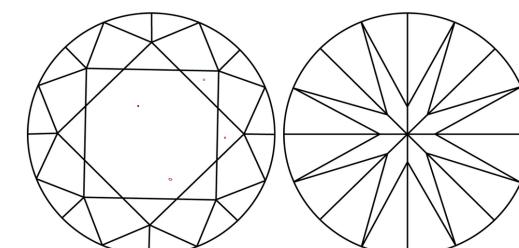
Type Ila

LG758517432  
Report verification at [igi.org](https://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

[www.igi.org](https://igi.org)

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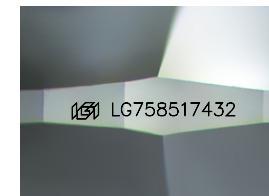
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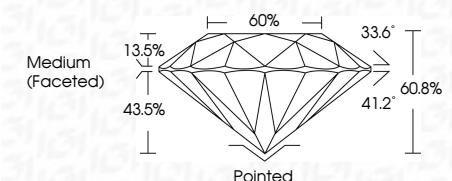
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Sample Image Used



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December 16, 2025  
IGI Report No LG758517432  
ROUND BRILLIANT  
8.12 - 8.15 X 4.94 MM  
Carat Weight: 2.01 CARATS  
Color Grade: E  
Clarity Grade: VS 2  
Cut Grade: IDEAL  
Depth: 60.8%  
Table: 43.5%  
Girdle: Medium (Faceted)  
Culet: Pointed  
Polish: EXCELLENT  
Symmetry: EXCELLENT  
Fluorescence: NONE  
Inscription(s): IGI LG758517432

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